



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/623,866 Confirmation No. : 6399  
First Named Inventor : Yoshihiro KATO  
Filed : July 22, 2003  
TC/A.U. : 1763  
Examiner : Jeffrie R. Lund  
Docket No. : 101246.52582US  
Customer No. : 23911  
Title : Plasma Process System and Plasma Process Method

**REPLY**

**Mail Stop Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In complete response to the Office Action dated June 23, 2005, the period of response having been extended to October 23, 2005 by the attached Petition for Extension of Time, please amend the above-captioned application as follows.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 7 of this paper.